

Electronic Patent Application Fee Transmittal

Application Number:	10824750
Filing Date:	15-Apr-2004
Title of Invention:	Method and system for immersion lithography using high PH immersion fluid
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Attorney Docket Number:	TSMC2003-1412(N1280-00280)

Filed as Large Entity

Utility Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 1 month with \$0 paid	1251	1	120	120

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	790	790
Total in USD (\$)				910